



PATENT  
8070-1003

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Tatsuya SUZUKI et al.

Appl. No. 10/685,571

Filed October 16, 2003

Conf. 7159

Group 2812

Examiner W.Lindsay, Jr.

METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE AND SEMICONDUCTOR DEVICE

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 11, 2005

Sir:

In response to the Office Action mailed March 10, 2005,  
please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing  
of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.

An **Appendix**, including a verified English translation  
of the priority Japanese application, is attached following the  
signature page of this paper.